# FIFTH-ORDER MOMENT CORRECTION FOR BEAM POSITION AND SECOND-ORDER MOMENT MEASUREMENT

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#### Abstract

For the precise measurement of beam positions and second-order moments, we adopted a recursive correction with up to fifth-order moments for a measurement using a six-electrode BPM at SPring-8 linac. The higher-order correction terms are provided by considering an effect from higher-order moments on the output voltages of BPM. We found huge calculation error in a simulated correlation plot between set and calculated vertical positions without correction. This error is also found in a similar correlation plot between the measured vertical positions with fifth-order moment correction and without it.

#### **INTRODUCTION**

For measurements of beam position and second-order relative moments [1], six-electrode BPMs with circular crosssection have been installed at SPring-8 linac [2].

To obtain the relative attenuation factors between the BPM electrodes, we developed a beam-based calibration method, i.e., entire calibration. During the entire calibration, beams must be located at a position more than 4 mm from the BPM center.

We also developed a recursive correction scheme with up to fifth-order moments to improve the accuracy of the entire calibration when a beam was located far from the BPM center [3].

Previously, correction terms were usually expressed by the higher-order polynomials of the beam positions for obtaining (calculating) precise beam positions [4]. Because the correction terms came from higher-order moments that appeared on the output voltages of BPM, we constructed a new correction scheme whose correction terms were expressed by higher-order moments.

This paper describes the theoretical features of the correction scheme, the simulation (calculation) by an image charge method, and the experiment results using electron beams at SPring-8 linac.

### THEORETICAL FEATURES

### Electric Field Calculation

Figure 1 shows the structure of a six-electrode BPM with a circular cross-section that is used at SPring-8 linac. Inner radius *R* is 16 mm, and the shared radius of each electrode is  $6/\pi$ .

Suppose an *M*-particle system where  $b_N$  and  $\beta_N$  are the distance from the BPM center and an argument from the x-axis for *N*th-charged particles (Fig. 1).

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Figure 1: Structure of six-electrode BPM with a typical three-particle system.

Because the electric field on inner surface  $E(\theta)$  is a superposition of the electric field generated by all the charged particles, i.e., a beam,  $E(\theta)$  is written as follows in Eq. (1) [1]:

$$E(\theta) \propto M + 2\sum_{n=1}^{\infty} \sum_{N=1}^{M} \frac{p_{Nn} \cos n\theta + q_{Nn} \sin n\theta}{R^n},$$
  

$$\propto 1 + 2\sum_{n=1}^{\infty} \frac{P_n \cos n\theta + Q_n \sin n\theta}{R^n},$$
  

$$p_{Nn} = b_N^n \cos n\beta_N, \ q_{Nn} = b_N^n \sin n\beta_N,$$
  

$$P_n = \frac{1}{M} \sum_{N=1}^{M} p_{Nn}, \ Q_n = \frac{1}{M} \sum_{N=1}^{M} q_{Nn}.$$
  
(1)

In Eq. (1),  $p_{Nn}$  and  $q_{Nn}$  are the *n*th-order moments of the *N*th-charged particle, and  $P_n$  and  $Q_n$  are the *n*th-order absolute moments [1] of the beam.

### Output Voltages from Electrode

The output voltage from the *d*th electrode  $(1 \le d \le 6)$  is written as Eq. (2) using geometrical factors  $c_{dn}$ ,  $s_{dn}$ :

$$V_d \propto R \int_{(4d-3)\pi/12}^{(4d-1)\pi/12} E(\theta) d\theta = \frac{\pi}{12} + \sum_{n=1}^{\infty} \frac{c_{dn} P_n + s_{dn} Q_n}{R^n},$$
  
$$c_{dn} = \int_{(4d-3)\pi/12}^{(4d-1)\pi/12} \cos n\theta d\theta, \ s_{dn} = \int_{(4d-3)\pi/12}^{(4d-1)\pi/12} \sin n\theta d\theta.$$
(2)

If we treat moments up to the fifth-order, all of the geometrical factors can be summarized as  $f_n$ ,  $h_n$   $(1 \le n \le 5)$  in

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Eq. (3):  

$$f_{1} = c_{11} = -c_{31} = -c_{41} = c_{61}, \ 0 = c_{21} = c_{51}, \\h_{1} = s_{11} = s_{31} = -s_{41} = -s_{61}, \ 2h_{1} = s_{21} = -s_{51}, \\f_{2} = c_{12} = c_{32} = c_{42} = c_{62}, \ 2f_{2} = -c_{22} = -c_{52}, \\h_{2} = s_{12} = -s_{32} = s_{42} = -s_{62}, \ 0 = s_{22} = s_{52}, \\0 = c_{13} = c_{23} = c_{33} = c_{43} = c_{53} = c_{63}, \\h_{3} = s_{13} = -s_{23} = s_{33} = -s_{43} = s_{53} = -s_{63}, \\f_{4} = -c_{14} = -c_{34} = -c_{44} = -c_{64}, \ 2f_{4} = c_{24} = c_{54}, \\h_{4} = s_{14} = -s_{34} = s_{44} = -s_{64}, \ 0 = s_{24} = s_{54}, \\f_{5} = -c_{15} = c_{35} = c_{45} = -c_{65}, \ 0 = c_{25} = c_{55}, \\h_{5} = s_{15} = s_{35} = -s_{45} = -s_{65}, \ 2h_{5} = s_{25} = -s_{55}. \end{cases}$$
(3)

### Differences of Output Voltages

To obtain the beam's *n*th-order moments, we carefully choose the differences of output voltages  $C_n$ ,  $S_n$ :

$$C_{1} = \frac{V_{1} - V_{3} - V_{4} + V_{6}}{V_{1} + V_{3} + V_{4} + V_{6}}, S_{1} = \frac{V_{1} + V_{3} - V_{4} - V_{6}}{V_{1} + V_{3} + V_{4} + V_{6}},$$

$$C_{2} = \frac{V_{1} + V_{3} + V_{4} + V_{6} - 2(V_{2} + V_{5})}{V_{1} + V_{3} + V_{4} + V_{6} + 2(V_{2} + V_{5})},$$

$$S_{2} = \frac{V_{1} - V_{3} + V_{4} - V_{6}}{V_{1} + V_{3} + V_{4} + V_{6}}, S_{3} = \frac{V_{1} - V_{2} + V_{3} - V_{4} + V_{5} - V_{6}}{V_{1} + V_{2} + V_{3} + V_{4} + V_{5} + V_{6}}.$$
(4)

Then we suppose that  $P_n$ ,  $Q_n$  can be expressed as a product of an *n*th power of effective aperture radius  $R_{CnPn}^n$ ,  $R_{SnQn}^n$  [2] and corrected difference  $C_n^{\dagger}$ ,  $S_n^{\dagger}$ , as shown in Eq. (5):

$$P_{1} = \frac{R_{C1P1}}{2}C_{1}^{\dagger}, Q_{1} = \frac{R_{S1Q1}}{2}S_{1}^{\dagger}, P_{2} = \frac{R_{C2P2}^{2}}{2}C_{2}^{\dagger},$$

$$Q_{2} = \frac{R_{S2Q2}^{2}}{2}S_{2}^{\dagger}, Q_{3} = \frac{R_{S3Q3}^{3}}{2}S_{3}^{\dagger}.$$
(5)

$$R_{C1P1} = \frac{\pi}{6f_1}R, \ R_{S1Q1} = \frac{\pi}{6h_1}R, \ R_{C2P2} = \sqrt{\frac{\pi}{9f_2}}R,$$

$$(6)$$

$$R_{S2Q2} = \sqrt{\frac{\pi}{6h_2}}R, \ R_{S3Q3} = \sqrt[3]{\frac{\pi}{6h_3}}R.$$

*Relations Between*  $C_n^{\dagger}$ ,  $S_n^{\dagger}$  and  $C_n$ ,  $S_n$ 

Because  $V_d$  is expressed as the linear combination of  $P_n$ and  $Q_n$  up to the infinite-order (Eq. (2)), we must confine the highest-order of the moments when  $P_n$ ,  $Q_n$  is calculated using the relation of Eq. (5).

If we only confine the fundamental (smallest) order, i.e., without correction, we obtain the following relations between  $C_n^{\dagger}$ ,  $S_n^{\dagger}$  and  $C_n$ ,  $S_n$ , as shown in Eq. (7):

$$C_1^{\dagger} = C_1, \ S_1^{\dagger} = S_1, \ C_2^{\dagger} = C_2, \ S_2^{\dagger} = S_2, \ S_3^{\dagger} = S_3.$$
 (7)

If we confine the correction with up to third-order moments, we obtain the following recursive relations of Eq. (8):

$$C_{1}^{\dagger} = C_{1} \left( 1 + \frac{2P_{2}}{R_{C1P2d}^{2}} \right), \quad S_{1}^{\dagger} = S_{1} \left( 1 + \frac{2P_{2}}{R_{S1P2d}^{2}} \right) - \frac{2Q_{3}}{R_{S1Q3u}^{3}},$$

$$C_{2}^{\dagger} = C_{2} \left( 1 - \frac{2P_{2}}{R_{C2P2d}^{2}} \right), \quad S_{2}^{\dagger} = S_{2} \left( 1 + \frac{2P_{2}}{R_{S2P2d}^{2}} \right), \quad S_{3}^{\dagger} = S_{3}.$$
(8)

 $R_{C1P2d} = \sqrt{\frac{\pi}{6f_2}} R, \ R_{S1P2d} = \sqrt{\frac{\pi}{6f_2}} R, \ R_{S1Q3u} = \sqrt[3]{\frac{\pi}{6h_3}} R,$  $R_{C2P2d} = \sqrt{\frac{\pi}{3f_2}} R, \ R_{S2P2d} = \sqrt{\frac{\pi}{6f_2}} R.$ (9)

If we confine the correction with up to fifth-order moments, we obtain the following recursive relations of Eq. (10):

$$C_{1}^{\dagger} = C_{1} \left( 1 + \frac{2P_{2}}{R_{C1P2d}^{2}} - \frac{2P_{4}}{R_{C1P4d}^{4}} \right) + \frac{2P_{5}}{R_{C1P5u}^{5}},$$

$$S_{1}^{\dagger} = S_{1} \left( 1 + \frac{2P_{2}}{R_{S1P2d}^{2}} - \frac{2P_{4}}{R_{S1P4d}^{4}} \right) - \frac{2Q_{3}}{R_{S1Q3u}^{3}} - \frac{2Q_{5}}{R_{S1Q5u}^{5}},$$

$$C_{2}^{\dagger} = C_{2} \left( 1 - \frac{2P_{2}}{R_{C2P2d}^{2}} + \frac{2P_{4}}{R_{C2P4d}^{4}} \right) + \frac{2P_{4}}{R_{C2P4u}^{4}},$$

$$S_{2}^{\dagger} = S_{2} \left( 1 + \frac{2P_{2}}{R_{S2P2d}^{2}} - \frac{2P_{4}}{R_{S2P4d}^{4}} \right) - \frac{2Q_{4}}{R_{S2Q4u}^{4}}, S_{3}^{\dagger} = S_{3}.$$

$$R_{C1P4d} = \sqrt[4]{\frac{\pi}{6f_{4}}}R, R_{C1P5u} = \sqrt[5]{\frac{\pi}{6f_{5}}}R, R_{S1P4d} = \sqrt[4]{\frac{\pi}{6f_{4}}}R,$$

$$R_{S1Q5u} = \sqrt[5]{\frac{\pi}{6h_{5}}}R, R_{C2P4d} = \sqrt[4]{\frac{\pi}{6h_{4}}}R,$$

$$R_{S2P4d} = \sqrt[4]{\frac{\pi}{6f_{4}}}R, R_{S2Q4u} = \sqrt[4]{\frac{\pi}{6h_{4}}}R.$$
(11)

### SIMULATION

To evaluate the effect of the correction, we calculated vertical position  $Q_1$  by changing sets  $P_1$ ,  $Q_1$ , and  $P_{g2}$  in the simulations. We regarded the other higher-order relative moments,  $Q_{g2}$ ,  $P_{g3}$ ,  $Q_{g3}$ ,  $P_{g4}$ ,  $Q_{g4}$ ,  $P_{g5}$ , and  $Q_{g5}$ , as zero because only  $P_{g2}$  was widely varied by normal (not skew) quadrupole magnets. Therefore, the higher-order absolute moments were explicitly written as Eq. (12):

$$P_{2} = p_{G2} + P_{g2}, \ p_{G2} = P_{1}^{2} - Q_{1}^{2}, \ Q_{2} = q_{G2} = 2P_{1}Q_{1},$$

$$P_{3} = p_{G3} + 3p_{G1}P_{g2}, \ p_{G3} = P_{1}^{3} - 3P_{1}Q_{1}^{2}, \ p_{G1} = P_{1},$$

$$Q_{3} = q_{G3} + 3q_{G1}P_{g2}, \ q_{G3} = 3P_{1}^{2}Q_{1} - Q_{1}^{3}, \ q_{G1} = Q_{1},$$

$$P_{4} = p_{G4} + 6p_{G2}P_{g2}, \ p_{G4} = P_{1}^{4} - 6P_{1}^{2}Q_{1}^{2} + Q_{1}^{4},$$

$$Q_{4} = q_{G4} + 6q_{G2}P_{g2}, \ q_{G4} = 4P_{1}^{3}Q_{1} - 4P_{1}Q_{1}^{3},$$

$$P_{5} = p_{G5} + 10p_{G3}P_{g2}, \ p_{G5} = P_{1}^{5} - 10P_{1}^{3}Q_{1}^{2} + 5P_{1}Q_{1}^{4},$$

$$Q_{5} = q_{G5} + 10q_{G3}P_{g2}, \ q_{G5} = 5P_{1}^{4}Q_{1} - 10P_{1}^{2}Q_{1}^{3} + Q_{1}^{5}.$$

The ranges of sets  $P_1$ ,  $Q_1$ , and  $P_{g2}$  are shown in Eq. (13):

$$-4 \leq \text{Set } P_1 \leq 4 \text{ [mm] by } 0.1 \text{ mm steps},$$
  
 $-4 \leq \text{Set } Q_1 \leq 4 \text{ [mm] by } 0.1 \text{ mm steps},$  (1)  
 $\text{Set } P_{g2} = -2, 11 \text{ [mm^2]}.$ 

 $E(\theta)$  was derived from two-dimensional electrostatic potentials evaluated by applying a method of images with a mirror point charge [1]. For providing  $P_{g2}$  to the simulation  $\odot$  we assumed an electric quadrupole.

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The simulated correlation plots are shown in Figs. 2, 3, and 4. The abscissa denotes set  $Q_1$ , and the ordinate denotes simulated  $Q_1$ . These figures only display the negative regions of  $Q_1$  (-4  $\leq$  set  $Q_1$ , simulated  $Q_1 \leq 0$ ).



Figure 2: Simulated  $Q_1$  without correction using Eq. (7).



Figure 3: Simulated  $Q_1$  with up to third-order moment correction using Eq. (8).



Figure 4: Simulated  $Q_1$  with up to fifth-order moment correction using Eq. (10).

Small calculation error was shown in the simulated  $Q_1$  with up to fifth-order moment correction (Fig. 4), but huge calculation error was found in the simulated  $Q_1$  without correction (Fig. 2).

## **COMPARISON WITH EXPERIMENT**

To prove the correction's validity, we carried out a beam experiment at SPring-8 linac. The electron beams were

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swept by horizontal and vertical steering magnets in a  $-4 \le P_1 \le 4$  [mm] and  $-4 \le Q_1 \le 4$  [mm] positional region.

Since we cannot determine the true beam positions, we chose  $Q_1$ , which was corrected with up to fifth-order moments instead of set  $Q_1$  as the parameter of abscissa (Figs. 5 and 6).



Figure 5: Correlation plot between  $Q_1$  with up to fifth-order moment correction and  $Q_1$  without it.



Figure 6: Correlation plot between  $Q_1$  with up to fifth-order moment correction and  $Q_1$  with up to third-order moment correction.

In the figures, the small red circles (simulation) and the large black circles (experiment) show good agreement, and this consistency proves the validity of higher-order moment correction.

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